

SPUTTERING TARGET FOR FORMING MAGNETIC RECORDING
FILM, AND CARBON RAW MATERIAL USED FOR PRODUCTION OF
SAID TARGET

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ABSTRACT

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A carbon powder for use in producing a sputtering target for forming a magnetic recording film, wherein the fluorine content is 50 wtppm or more; and a sputtering target for forming a magnetic recording film which is prepared by the sintering method using the foregoing carbon powder. The present invention aims to provide a high-density sputtering target which enables the production of a magnetic thin film having a granular structure without using an expensive cosputtering equipment, and the reduction in the amount of particles that are generated during sputtering.

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